

03500.016072.1

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In. Application of: )  
: Examiner: Long Pham  
MINEO SHIMOTSUSA, ET AL. )  
: Group Art Unit: 2814  
Application No.: 10/657,269 )  
:   
Filed: September 9, 2003 )  
:   
For: SEMICONDUCTOR DEVICE, )  
METHOD FOR )  
MANUFACTURING THE )  
SAME, AND LIQUID JET )  
APPARATUS ) March 29, 2005

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT


Sir:

In response to the Office Action dated November 29, 2004, the period for response to which having been extended to March 29, 2005 by the accompanying Petition for Extension of Time with fee, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 29, 2005  
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicant)

  
Signature

March 29, 2005  
Date of Signature